INFORMATION ABOUT THE FINAL EXAM

Office Hours During Finals Week:

To help with your project and with any questions over the period before and during Finals Week, the following office hours will be held:

Prof. Nguyen
- 10-11:30 a.m. on Wednesday, Dec. 10
- 2-3:30 p.m. on Friday, Dec. 12
- 2:30 – 4 p.m. on Monday, Dec. 15
- 10 – 11:30 a.m. on Tuesday, Dec. 16
- 2-3:30 p.m. on Friday, Dec. 19

Mehmet Akgul
- 11-12 noon on Monday, Dec. 15
- 11-12 noon on Tuesday, Dec. 16

Ilya Gurin
- 3-4 p.m. on Wednesday, Dec. 10
- 11-12 noon on Thursday, Dec. 11
- 3-4 p.m. on Wednesday, Dec. 17
- 11-12 noon on Thursday, Dec. 18

Date of Exam:

Exam Group 20: Saturday, Dec. 20, 12:30-3:30 p.m. (sharp)

Place:

247 Cory Hall

General Information:

The exam will be closed book, but you will be allowed 4 sheets, front and back, on which you can write anything you would like. Bring a calculator to the exam. You will be provided with exam sheets with enough space to put all your work on these sheets. You should show and include all your work on the exam sheets. The exam will consist of a few problems, each with a number of parts.

Material to be Covered:

Reading in Senturia, class lecture notes, handouts, and homeworks. The exam is meant to include all material covered in the class, with stronger emphasis on material covered after the Midterm Exam. A summary of important topics that might be covered on the Final Exam can be listed as follows:

1. Basic MEMS fabrication process modules, including oxidation, film deposition, lithography, etching, ion implantation, and diffusion. You should especially have a good understanding of MEMS-centric etching and what influences selectivity and the degree of anisotropy.
2. Physics of stiction and bending/warping due to residual or thermal stresses and other phenomena. Be able to quantitatively determine whether a particular structure is warped or stuck down.

3. MEMS process flow design and layout. Be prepared to design your own process flow and layout for some arbitrary cross-section or 3D structure.

4. Surface micromachining, including its basic process flow, release issues (e.g., stiction), material choices, residual stress, stringers and methods for eliminating them.

5. Mechanics of materials for MEMS, including stress, strain, material properties, and on-chip measurement & characterization of mechanical properties.

6. Microstructural elements, including bending moment and strain, flexural rigidity, residual stress analysis, boundary conditions, and spring combinations. You should be familiar with beam bending equations and their application. You should also be able to derive properties for arbitrary connections of beams (i.e., springs).

7. Pros and cons of scaling, including understanding of thermal circuits and impact of scaling on surface-to-volume ratios.


9. Input/output transducer modeling, including energy methods and construction of equivalent circuits. Here, you should understand first and second order effects for both parallel-plate and comb-capacitive transducers, including electrical stiffness and levitation.

10. Micromechanical circuit analysis, including specification of the equivalent circuit for a micromechanical device with multiple ports and determination of the output variables (e.g., current, voltage, displacement, velocity) at the various ports when emplaced into a circuit of other elements (e.g., resistors, capacitors, etc.).

11. Sensing circuits, including topologies that minimize parasitics. Be able to analyze circuit topologies and make the right choice of which circuit to use to grab a desired output variable.

12. Gyroscope operation and scale factor. Be able to determine how scale factor changes with changes in a given environmental variable.

13. Noise, especially noise modeling in mechanical systems.

14. Methods for determining the resolution of a sensor that include the ability to determine a sensor’s scale factor, to generate a complete equivalent circuit for an electromechanical system, and to determine the noise sources important for a given sensor element.

Practice Material:

To give you some semblance of what to expect, the solutions to last year’s Final Exam are online. Note that the material coverage between last year and this year differ slightly (e.g., some things were emphasized more than others), and last year’s exam was open book, so might not be fully representative of what your exam might look like. However, it still gives you some sample problems on which to practice. And as always, practice is one of the best ways to do well on an engineering exam. In fact, a good way to study for this exam is to make up some of your own problems and solve them.